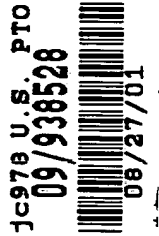


12-7-01
Docket: 740819-634



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Koji ARITA et al.)
Japanese Priority Application. 2000-263466) Attn: Applications
Japanese Priority Date: August 31, 2000) Branch
For: METHOD FOR MANUFACTURING)
A SEMICONDUCTOR DEVICE) Date: August 27, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
Washington, D.C. 20231

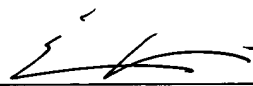
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

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